

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): JIN et al.

Serial No.: 09/621,717

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Title: Structure and Method for Monitoring
a Semiconductor Process, and Method
of Making Such a Structure

Attorney Docket No.: CY-0013

Group Art Unit: 2822

Examiner: Thomas, T.

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AMENDMENT AFTER FINAL ACTION
(37 C.F.R. §1.116)Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313A. Introductory CommentsThe following is submitted in response to the FINAL Office Action dated
November 18, 2003, and is currently due February 18, 2004.37 C.F.R. §1.8

15 I hereby certify that this correspondence is being

[X] transmitted via facsimile to the United States Patent and Trademark Office to fax number: 1-703-872-9306Date of Transmittal: February 17, 200420 [] deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for
Patents, P.O. Box 1450, Alexandria, VA 22313.

Date of Deposit: _____

25 Typed/Printed Name: Bradley T. SakoSignature: Bradley T. Sako

Response to Office Action - Page 1 of 8

Okay to enter. JMS 06/01/04